## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

App. No. : 10/708,224

Applicant : Masuhiro Natsuhara

Filed: February 18, 2004

T.C./A.U. : 3742

Examiner : Sang Yeop Paik

Docket No. : 39.033

Customer No. : 29453

Honorable Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

For the reasons stated below, Applicants have requested a panel review of the legal and factual basis of the rejections, made final, in the Office action of March 8, 2006 in the above-identified patent application.

## ARGUMENTS Accompanying Pre-Appeal Brief Request for Review

- 1. The lone rejection of the pending claims in this case, claims 1 through 4, is under 35 U.S.C. § 103 over a single reference, U.S. Pat. No. 6,071,465 to Kobayashi, presumably in combination with knowledge of those skilled in the wafer holder arts. Applicants submit that the examiner's *prima facie* case in support of this rejection, now repeated verbatim and made final, is deficient for at least two reasons: lack in the factual basis; and error in the reasoning.
- 2. The examiner has not presented factual evidence that aligning "the center of the supporting shaft (. . .) with the center of the substrate"—as the examiner alleges is shown in the figures of Kobayashi—leads to a device that *completely* meets the limitations of claim 1 of the present application. Specifically, the examiner has not pointed to any showing in Kobayashi that distance between the axial center of the wafer-carrying side of the "disk-shaped base 37" of the heating apparatus illustrated in Fig. 10 (the only relevant figure) of Kobayashi, and the axial center

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of the "tube-shaped body 35" is 5% or less of the diameter of the wafer-carrying side.

- 3. Granting that the motivation that the Office gives to combine references, or a lone reference with a skilled artisan's knowledge, need not match the motivation that inspired the inventors, the examiner has failed to demonstrate that the motivation he mentions would in fact lead to a combination that meets each and every limitation of Applicants' claim 1—and most specifically, the limitation just quoted. The examiner has merely made a general statement that Kobayashi shows "that the center of the supporting shaft is aligned with the center of the substrate" and that a person skilled in the art would have been motivated to have the alignment be "within the claimed range to prevent imbalancing of the substrate on the supporting shaft." But the examiner has failed to demonstrate how the Kobayashi device, thus modified "to prevent imbalancing" would meet Applicants' claim 1 limitation with regard to the wafer-carrying side of a wafer holder.
- 4. Furthermore, under Response to Arguments in the final Office action, the examiner states

Kobayashi[,] realizing the importance of having . . . proper machined surfaces and the flatness of the device that is in a micro scale[,] would have been further motivated to achieve a stable balance of the substrate with respect to the shaft to ensure a desired heating distribution along the heating surface.

- 5. Notwithstanding the above-quoted comment by the examiner, Applicants submit that the examiner is applying hindsight reasoning, and that consequently the examiner has not made a proper *prima facie* case of the obviousness of claim 1 over the Kobayashi reference (in combination with the common knowledge of those skilled in the art).
- 6. That is, in addressing the surface limitations recited in claim 1 of the present invention, the examiner uses hindsight reasoning in making his statements about Kobayashi "realizing the importance of having . . . proper machined surfaces and the flatness" in the relevant components of his device, and being "motivated to achieve a stable balance of the substrate with respect to the shaft to ensure a desired heating distribution along the heating surface."
- 7. Therefore, Applicants submit that such hindsight reasoning constitutes a factual deficiency in the examiner's rejections.

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Remarks

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It is believed that the present paper, as attached to form PTO/SB/33, "Pre-Appeal Brief Request for Review," constitutes a properly filed request for panel review. Accordingly, Applicants earnestly solicit a panel decision based on the panel's review of Applicants' remarks and the examiner's rejections.

Respectfully submitted,

September 8, 2006

## /James Judge/

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